

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Gerrit Cornelis DUBBELDAM

Application No.: 10/563,761

Filed: March 8, 2006

Docket No.: 126548

For: PROCESS FOR MANUFACTURING A SOLAR CELL FOIL USING A TEMPORARY  
SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 6-8 & 11.
- ☒ 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 3 & 8-14.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. An English language Abstract of one or more non-English language reference is attached hereto. See References 10 & 12-14.
- ☒ 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 14.

- ☒ 7. Please note: Reference 1 corresponds to Reference 8.  
Reference 2 corresponds to Reference 10.  
Reference 4 corresponds to Reference 11.  
Reference 5 corresponds to Reference 12.

Respectfully submitted,



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WPB:RBI/jrb

Date: April 14, 2006

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 126548		APPLICATION NO. 10/563,761	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT Gerrit Cornelis DUBBELDAM  FILING DATE March 8, 2006			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	6,184,057 B1	02/06/2001	Van Andel et al.			
	2	4,697,042	09/29/1987	Schilling			
	3	5,637,510	06/10/1997	Morikawa et al.			
	4	2001/0037823 A1	11/08/2001	Middelman et al.			
	5	6,613,598 B1	09/02/2003	Middelman et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	6	WO 99/049483	09/30/1999	WIPO			
	7	WO 01/78156 A1	10/18/2001	WIPO			
	8	WO 98/13882	04/02/1998	WIPO			
	9	WO 03/001602 A2	01/03/2003	WIPO			
	10	EP 0 210 451 A2	02/04/1987	Europe	X		
	11	WO 01/047020 A1	06/28/2001	WIPO			
	12	EP 0 098 004 A1	10/06/1999	Europe	X		
	13	DE 39 35 826 A1	06/13/1990	Germany	X		
	14	JP A 10-093125	04/10/1998	Japan	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
	15	R.E.I. Schropp et al., "Novel Amorphous Silicon Solar Cell Using a Manufacturing Procedure with a Temporary Superstrate." Amorphous and Heterogeneous Silicon Thin Films: Fundamentals to Devices - 1999. Materials Research Society Symposium Proceedings, Vol. 557, pp. 713-718.					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: April 14, 2006